

## HE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: Unassigned Examiner: Unassigned

## In Re PATENT APPLICATION Of:

Applicants	:	Hiroomi TSUTAE	)
Serial No.	:	To Be Assigned	)
Filed	:	September 9, 2003	)
For	:	PROCESS OF CLEANING A SEMICONDUCTOR MANUFACTURING SYSTEM AND METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	) PRELIMINARY ) AMENDMENT ) )
Attorney Ref.	:	FUJI 136	) )

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits, please amend the application as follows:

Please charge any further fee to our Deposit Accoun

No. 18-0002